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APR 13 2006

**METHOD OF FABRICATING SILICON CARBIDE-CAPPED COPPER
DAMASCENE INTERCONNECT**

Appl. No. : 10/711,015 Confirmation No. 5014
Applicant : Jei-Ming Chen,
 Chin-Hsiang Lin,
 Chih-Chien Liu,
 Kuo-Chih Lai
Filed : August 18, 2004
TC/A.U. : 2826
Examiner : Quinto, Kevin V
Docket No. : NAUP0596USA0
Customer No. : 27765

Commissioner for Patents
P.O. Box 1450
Alexandria VA 22313-1450
Subject: Request for Continued Examination (RCE) in response to the advisory
5 action mailed 03/15/2006

INTRODUCTORY COMMENTS

In response to the Office action identified above, a request for continued examination (RCE) is made and the above-identified application is to be amended as indicated in the following sections. No new matter has been introduced by these 10 amendments. A continued examination and consideration of all amendments are politely requested.

Amendments to the Claims are reflected in the listing of claims beginning on page 2 of this paper.

Remarks begin on page 5 of this paper.